

[See all 2 Products in Family](#)

13.5nm, 25.4mm Dia, 5° AOI, EUV Flat Mirror



Extreme Ultraviolet (EUV) Flat Mirrors

Stock #38-759 **8 In Stock**

1 MRP ₹2,77,448

Price inclusive of all taxes

ADD TO CART

Volume Pricing	
Qty 1+	₹2,77,448 each
Need More?	Request Quote

Product Downloads

General

Flat Mirror **Type:**

Physical & Mechanical Properties

25.40 ±0.25 **Diameter (mm):**

6.35 ±0.508 **Thickness (mm):**

Commercial Polish **Back Surface:**

90	Clear Aperture (%):
Fine Ground	Edges:
3	Parallelism (arcmin):
<5 RMS	Surface Roughness (\square):

Optical Properties

Metal/Semiconductor	Coating Type:
Mb/Si Multilayer Top Layer: Silicon	Coating:
$\lambda/10$ @ 632.8nm	Surface Flatness (P-V):
13.18 - 13.68	Wavelength Range (nm):
13.5	Design Wavelength DWL (nm):
Single Crystal Silicon	Substrate: <input type="checkbox"/>
5	Angle of Incidence ($^{\circ}$):
$R_{\text{abs}} > 60\%$ @ 13.5nm, 5° (s-pol)	Coating Specification:
10-5	Surface Quality:
>60	Reflection at DWL (%):
0.50	Full Width-Half Max FWHM (nm):

Electrical

92	Center Energy (eV):
----	----------------------------

Regulatory Compliance

View	Certificate of Conformance:
United States	Country of Origin:
Edmund Optics India Private Limited 267, Greystone Building, Second Floor, 6th Cross Rd, Binnamangala, Stage 1, Indiranagar, Bengaluru, Karnataka, India 560038 Phone: +91- 80-6845 0000	Imported By:

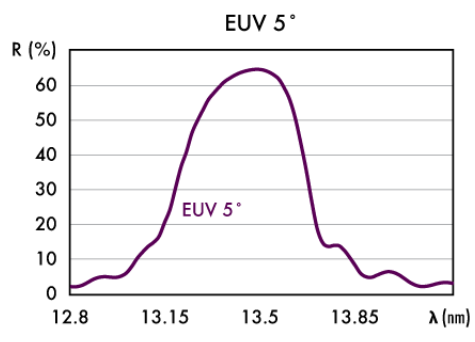
Product Details

- Maximum Achievable Reflection at 13.5nm
- Designed for EUV Beam Steering and Harmonic Separation
- 5° and 45° AOI Versions Available

Extreme Ultraviolet (EUV) Flat Mirrors are multilayer mirrors designed for maximum achievable reflectance at the design wavelength and angle of incidence. These mirrors feature a coating deposited on a super-polished single crystal silicon substrate and surface roughness less than $3 \square$ RMS. The 45° AOI mirrors are useful for steering s-polarized beams, while the 5° AOI mirrors may be used with unpolarized beams. Applications for EUV mirrors include Coherent Diffractive Imaging (CDI) and materials science research. Extreme Ultraviolet (EUV) Flat Mirrors can also serve as harmonic selectors for High Harmonic Generation (HHG) beams.

Note: Test data from each mirror's production run sample included.

Technical Information



Compatible Mounts

;